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Docket No.: M4065.0747/P747
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Howard E. Rhodes

Application No.: 10/663,694

Confirmation No.: 3975

Filed: September 17, 2003

Art Unit: 2823

For: MASKED SPACER ETCHING FOR
IMAGERS

Examiner: J. A. Garcia

RESPONSE TO RESTRICTION REQUIREMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed May 19, 2004 (Paper No. 0513), Applicant hereby elects claims 1-66 for continued examination. The Examiner has required restriction between:

Group I, claims 1-66, drawn to method, classified in class 438, subclass 230; and

Group II, claims 67-83, drawn to device, classified in class 257, subclass 204.

Applicant hereby elects Group I, claims 1-66 for continued examination, without traverse.

Dated: May 28, 2004

Respectfully submitted,

By 

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